



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Hideaki Kuwabara et al. Art Unit : Unknown
 Serial No. : 10/735,767 Examiner : Unknown
 Filed : December 16, 2003
 Title : SEMICONDUCTOR DEVICE AND METHOD FOR MANUFACTURING THE SAME

MAIL STOP AMENDMENT

Commissioner for Patents
 P.O. Box 1450
 Alexandria, VA 22313-1450

INFORMATION DISCLOSURE STATEMENT

Applicants request consideration of the references listed on the attached PTO-1449 form.
 Under 37 C.F.R. § 1.98 (a)(2)(ii), only copies of foreign patent documents and/or non-patent literature are enclosed. Copies of any listed U.S. patents or U.S. patent application publications can be provided upon request.

This statement is being filed before the receipt of a first Office Action on the merits.
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Respectfully submitted,

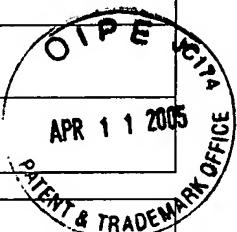


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Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 12732-189001	Application No. 10/735,767
Information Disclosure Statement by Applicant (Use several sheets if necessary) (37 CFR §1.98(b))		Applicant Hideaki Kuwabara et al.		
		Filing Date December 16, 2003	Group Art Unit	

**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	2003-0025118	02/06/2003	YAMAZAKI et al.			07/22/2002
	AB	2003-0032210	02/13/2003	TAKAYAMA et al.			07/15/2002
	AC	2003-0047280	03/13/2003	TAKAYAMA et al.			08/14/2002
	AD	2003-0064569	04/03/2003	TAKAYAMA et al.			08/09/2002
	AE	2003-0082889	05/01/2003	MARUYAMA et al.			10/30/2002
	AF	2003-0217805	11/27/2003	TAKAYAMA et al.			05/16/2003
	AG	2004-0087110	05/06/2004	TAKAYAMA et al.			07/15/2003
	AH	2004-0121516	06/24/2004	YAMAZAKI et al.			12/08/2003
	AI	2004-0140547	07/22/2004	YAMAZAKI et al.			12/09/2003
	AJ	2004-0232413	11/25/2004	YAMAZAKI et al.			10/29/2003
	AK						

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Sub-class	Translation	
							Yes	No
	AL	JP2000-061785	29 FEB 2000	JAPAN			Abstract	
	AM							
	AN							
	AO							
	AP							

Other Documents (include Author, Title, Date, and Place of Publication)

Examiner Initial	Desig. ID	Document
	AQ	
	AR	
	AS	
	AT	

Examiner Signature	Date Considered
EXAMINER: Initials citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.	